



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG821646318
Report verification at igi.org

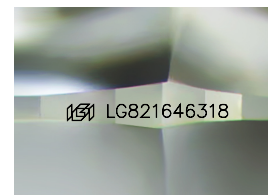
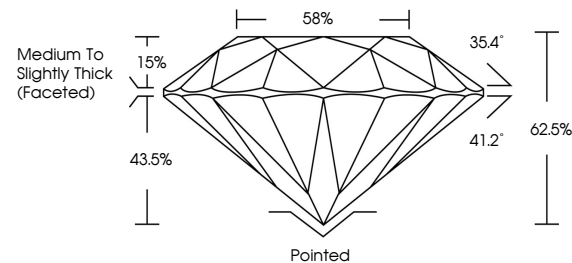
August 8, 2026	
IGI Report Number	LG821646318
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	6.38 - 6.42 X 4.00 MM
GRADING RESULTS	
Carat Weight	1.02 CARAT
Color Grade	D
Clarity Grade	VVS 1
Cut Grade	IDEAL

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG821646318

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

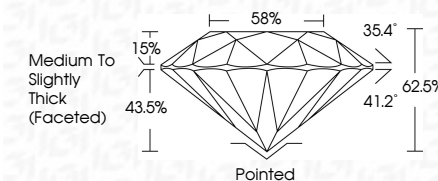
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

August 8, 2026
IGI Report No LG
ROUND BRILLIANT

3.38 - 6.42 X 4.00 MM	Card Weight	1.02 CARAT
	Color Grade	D
	Clarity Grade	VVS 1
	Cut Grade	IDEAL
	Depth	62.5%
	Table	58%
	Girdle	Medium to Slightly Thick (Faceted)
	Culet	Pointed
	Polish	EXCELLENT
	Symmetry	EXCELLENT
	Fluorescence	NONE

Comments:
This Laboratory Grown Diamond was
created by Chemical Vapor Deposition
(CVD) growth process.